

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

JFW

In re the Application of

Toshihiko TSUJI et al.

Application No.: 10/585,001

Filed: June 29, 2006

Group Art Unit: 2881

Docket No.: 128591

For: AN EXPOSURE APPARATUS AND DEVICE MANUFACTURING METHOD

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
 P.O. Box 1450
 Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the reference(s) listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the reference(s) be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

- 1. This Information Disclosure Statement is being filed (a) within three months of the U.S. filing date of this non-CPA application, OR (b) before the mailing date of a first Office Action on the merits in the present application. No certification or fee is required.
- 2. One or more reference cited herein was cited in a counterpart foreign application. An English language version of the European Search Report is attached for the Examiner's information. See References 1-4.
- 3. WO 99/49504 A and JP-A-06-204108 which are cited in the European Search Report were previously filed in an Information Disclosure Statement filed on June 29, 2006.

Respectfully submitted,

Mario A. Costantino
 Registration No. 33,565

John A. Radi
 Registration No. 59,345

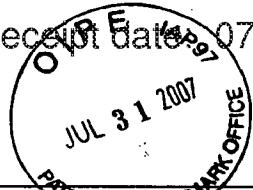
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Date: July 31, 2007
OLIFF & BERRIDGE, PLC
 P.O. Box 19928
 Alexandria, Virginia 22320
 Telephone: (703) 836-6400

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ALL REFERENCES CONSIDERED EXCEPT WHERE LINED THROUGH H. /A.S./



Sheet 1 of 1

Form PTO-1449 (REV. 1/06)		US Dept. of Commerce PATENT & TRADEMARK OFFICE		ATTY DOCKET NO. 128591	APPLICATION NO. 10/585,001
INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary)		APPLICANT(S) Toshihiko TSUJI et al.			
				FILING DATE June 29, 2006	GROUP 2881
U.S. PATENT DOCUMENTS					
Examiner Initials	Cite No.	Document Number	Date	Name	
FOREIGN PATENT DOCUMENTS					
Examiner Initials	Cite No.	Document Number	Date	Country	With English Abstract With English Translation
/A.S./	1	EP 1 143 492 A1	10/10/2001	Europe	
/A.S./	2	EP 0 834 773 A2	04/08/1998	Europe	
/A.S./	3	EP 1 477 858 A2	11/17/2004	Europe	
/A.S./	4	EP 1 477 856 A1	11/17/2004	Europe	
OTHER DOCUMENTS					
Examiner Initials	Cite No.	(Including Author, Title, Date, Pertinent Pages, etc.)			
EXAMINER <i>/Andrew Smyth/ (03/26/2008)</i>				DATE CONSIDERED	
Examiner: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.					